

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S21	268	S20 and @pd>"20040922"	US-PGPUB; USPAT; USOCR	OR	OFF	2005/03/09 09:14
S20	2424	((257/59) or (349/43)).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/03/09 09:14
S6	2156	((257/59) or (349/43)).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/03/09 09:14
S22	5	("5349205" "5648293" "5840602" "5917564" "6599790").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/03/09 09:44
S23	6	JP-06077483-\$.did. or JP-07045833-\$.did. or JP-07135319-\$.did. or JP-08255917-\$.did.	EPO; JPO; DERWENT	OR	OFF	2005/03/09 09:52
S24	361	257/55	US-PGPUB; USPAT; USOCR	OR	OFF	2005/03/09 09:53
S26	108	(257/63).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/03/09 09:56
S25	201	(257/55).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/03/09 09:56
S28	867	(257/77).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/03/09 10:38
S27	147	kaneko.in. and (amorphous adj silicon)	US-PGPUB; USPAT; USOCR	OR	OFF	2005/03/09 10:38
S29	110	S28 and (amorphous adj silicon)	US-PGPUB; USPAT; USOCR	OR	OFF	2005/03/09 10:50
S30	147	S27 and (amorphous adj silicon)	US-PGPUB; USPAT; USOCR	OR	OFF	2005/03/09 10:51
S31	8	S27 and (doped adj amorphous adj silicon)	US-PGPUB; USPAT; USOCR	OR	OFF	2005/03/09 11:55
S33	395	S32 and ((thin adj film) or tft)	US-PGPUB; USPAT; USOCR	OR	OFF	2005/03/09 11:57
S32	417	(gate adj insulating adj (film or layer)) with (organic and (oxide or nitride))	US-PGPUB; USPAT; USOCR	OR	OFF	2005/03/09 11:57
S34	420	(amorphous adj silicon) with (band adj gap)	US-PGPUB; USPAT; USOCR	OR	OFF	2005/03/09 12:03

S7	407	(amorphous adj silicon) with (band adj gap)	US-PGPUB; USPAT; USOCR	OR	OFF	2005/03/09 12:03
S35	124	S34 and @pd>"20000101"	US-PGPUB; USPAT; USOCR	OR	OFF	2005/03/09 12:04
S36	3	("6,597,415") or ("6,243,146") or ("6,057,896")).PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/03/09 12:09